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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/791,396
Applicant : Jeffry J. Sniegnowski et al
Title : MEMS Flow Module with Filtration
and Pressure Regulation Capabilities
Filed : April 18, 2005
T.C./A.U. : 3743
Examiner : Leslie R. Deak
Docket No. : P-7239
Confirmation No. : 2579

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Attn: Mail Stop Amendment

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated February 28, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.